



IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Mail Stop: ISSUE FEE**  
Takahisa HAYASHI : **Confirmation No. 6435**  
Serial No. 10/699,734 : [Group Art Unit 2826  
Filed November 4, 2003 : Examiner Victor A. Mandala]

SEMICONDUCTOR  
DEVICE AND METHOD OF  
MANUFACTURING THE SAME

**AMENDMENT UNDER 37 CFR 1.312 - AFTER**  
**RECEIPT OF NOTICE OF ALLOWANCE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

Sir:

Kindly amend the above-identified application as follows.